Search Notes	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/005,959	PEEV ET AL.
	Examiner	Art Unit
	J. Derek Rutten	2192

SEARCHED

Class	Subclass	Date	Examiner
717	136,174	9/9/2005	JDR
707	202	9/9/2005	JDR
704	15	9/9/2005	JDR

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
717	136,174	9/9/2005	JDR
707	202	9/9/2005	JDR
704	15	9/9/2005	JDR

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB) - see search history printout	8/17/2005	JDR
717/168-178 - text search only - see search history printout	8/23/2005	JDR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB) - see search history printout	8/23/2005	JDR
USPN 6366898	8/24/2005	JDR
Chameli Das (consulted re. allowability)	9/9/2005	JDR
ACM - portal.acm.org IEEE - ieeexplore.ieee.org (see search history printout)	9/9/2005	JDR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB) - see search history printout	9/9/2005	JDR